

10/782593

**EAST Search History**

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	37883	(MEMS or microelectromechanical or micro-electro-mechanical or (micro adj electro adj mechanical))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2007/07/05 16:58
S2	177519	((fixed or stationary) adj2 (plate\$1 or wafer\$1 or substrate\$1 or board\$1))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2007/07/05 16:59
S3	137889	((actuat\$3 or moving\$3 or moveable or movable or electrostatic\$4) adj2 (plate\$1 or wafer\$1 or substrate\$1 or board\$1))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2007/07/05 17:00
S4	1067821	(time with signal\$1)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2007/07/05 17:01
S5	191910	(array\$1 with circuit\$2)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2007/07/05 17:01
S6	1	S2 same S3 same S4 same S5	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2007/07/05 17:01
S7	34	S1 and S2 and S3 and S4 and S5	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2007/07/05 17:02
S8	33	S7 not S6	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2007/07/05 17:02